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Synchrotron Radiation: Generation and Application in Accelerator Physics

Laura Torino













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February 5, 2014 Pisa, Italy

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SYNCHROTRON RADIATION

GENERATION

APPLICATION

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SYNCHROTRON RADIATION

The electromagnetic radiation emitted when a high energetic charged particle is accelerated radially is called *Synchrotron Radiation*

- High radiation flux
- High brilliance
- Wide radiation spectrum
- ► Tunability
- Defined polarization



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CHARACTERISTICS



- ψ : Emission angle
- ω : Radiation frequency
- c: Speed of light
- *r*₀: Classical electron radius
- p_T : Transverse momentum
 - γ : Lorentz factor

$$\omega_c: \frac{3c\gamma^3}{2\rho} = \frac{\varepsilon_c}{\hbar}$$

 F_{σ}, F_{π} : Combination of Airy functions

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Observed Power Distribution

$$\frac{\mathrm{d}^2 P_{ob}(\omega,\psi)}{\mathrm{d}\omega \mathrm{d}\psi} = \frac{4\pi c r_0 \dot{p}_T^2 \gamma^3}{3\omega_c m c^2} (F_\sigma(\omega,\psi) + F_\pi(\omega,\psi))$$

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POWER DISTRIBUTION



POWER DISTRIBUTION



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SYNCHROTRON RADIATION

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SYNCHROTRON LIGHT SOURCES

Because of its peculiar characteristics synchrotron radiation used for experiments is produced at dedicated accelerator facilities with specific characteristics

- ▶ Electron beam energy (≃ GeV)
- Low emittance $(\simeq 10 \text{ nm rad})$
- Full energy injection system
- Compact lattice to insert Insertion Devices
- High reliability



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SYNCHROTRON RADIATION GENERATION

To provide synchrotron radiation to experiments three different devices are used:

Bending Magnet

Wiggler/Undulator



Part of the machine



Inserted in straight sections

WIGGLERS VS UNDULATORS

High photon flux \downarrow Increase the number of magnetic poles

$$K = \frac{eB\lambda_0}{2\pi\beta mc} \simeq 0.0934B[T]\lambda_0[mm]$$

Wigglers *K* >> 1 Increase the photon energy

- $\varepsilon_c[\text{keV}] =$ 0.665 $B[\text{T}]E^2[\text{GeV}^2]$
- High magnetic field are used

Undulators $K \simeq 1$ Quasi-monochromatic radiation

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$$\lambda_0 = \left(\frac{1}{\beta} - 1\right)L$$

 Interference between the light produced by the same electron at each wiggle

GENERATED RADIATION





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BEAMLINES

Once produced the radiation is guided to the beamlines



BEAMLINES

Once produced the radiation is guided to the beamlines



SYNCHROTRON RADIATION

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BEAM DIAGNOSTIC USING SR



Advantages

- Produced "for free"
- ► Wide spectrum
- ► Real-time
- Non-invasive

Disadvantages

- Need of a source
- Radiation exposure
- "Only" for light particle

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Machine design

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BEAM DIAGNOSTIC USING SR

SR characteristics Beam characteristics

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Disadvantages

- Need of a source
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Machine design

Visible radiation coming from a bending and extracted through a mirror chicane

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DIAGNOSTIC BEAMLINE



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DIAGNOSTIC BEAMLINE



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DIAGNOSTIC USING SR

Transverse beam measurements

- Beam size (X-Rays)
- ► Beam size (Visible)

Longitudinal beam measurements

- Filling pattern
- Bunch size



BEAM SIZE-PINHOLE

Problem

Electron machines \Rightarrow Beam size \simeq tens of μ m or smaller \updownarrow Diffraction limited using visible radiation ψ $d = \frac{\lambda}{2u\sin\theta} \simeq 100\mu$ m

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BEAM SIZE-PINHOLE

Problem

Electron machines \Rightarrow Beam size \simeq tens of μ m or smaller \updownarrow Diffraction limited using visible radiation \Downarrow $d = \frac{\lambda}{2\pi \sin \theta} \simeq 100 \mu$ m



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Solution Use X-Rays ↓ Need a different frontend & Need a device set-up suitable for X-Rays



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Solution

Use X-Rays ↓ Need a different frontend & Need a device set-up suitable for X-Rays



- X-Rays $\simeq 40 \, \text{keV}$
- ▶ Enlarge Factor ≃ 2:5
- Hole $\simeq 10 \,\mu \text{m}$
- YAG screen + CCD camera

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BEAM SIZE-INTERFEROMETRY

Measurement of the first order of spatial coherence of the synchrotron radiation using a double slit interferometer

$$\sigma = \frac{\lambda d_0}{\pi D} \sqrt{\frac{1}{2} \ln \frac{1}{V}} \qquad \qquad V = \frac{I_{Max} - I_{Min}}{I_{Max} + I_{Min}}$$



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$$V = \frac{I_{Max} - I_{Min}}{I_{Max} + I_{Min}}$$

Using good quality optical components \downarrow Beam size < 10 μ m can be achieved



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LONGITUDINAL MEASUREMENTS

The longitudinal structure of a circular accelerator is defined by the beam revolution period and the accelerating RF-frequency $h = T \times f_{RF}$ The machine is divided into *h* **Buckets**. Each bucket can be filled with a bunch



Filling Pattern

The scheme of distribution of bunches among the machine buckets

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SYNCHROTRON RADIATION	GENERATION	APPLICATION
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FILLING PATTERN-TCSPC

Time Correlated Single Photon Counting



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FILLING PATTERN-TCSPC



FILLING PATTERN-TCSPC



Dynamic Range better than $10^3 \Rightarrow$ Also bunch purity experiments

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BUNCH LENGTH-STREAK CAMERA





NOT ONLY SLS!

Electron Machines/Linear Collider



LHC

- ► Bunch Purity with TCSPC
- Imaging
- Interferometry

Possibility of using undulators to increase the photon flux

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Muon Storage Rings

Need to know the muon energy \Rightarrow Measure the μ g-2 using SR emitted by muon decay electrons

 $\omega_a = a_\mu \gamma \omega_{cic}$

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SUMMARY

- Synchrotron radiation
 - Physical characteristics
- Synchrotron Radiation generation
 - Insertion Devices
- Application in machine diagnostic
 - Transverse beam size
 - Longitudinal measurements

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